

<b>Notice of References Cited</b>	Application/Control No. 10/579,835		Applicant(s)/Patent Under Reexamination TELIMAA ET AL.	
	Examiner Dwan A. Gerido, Ph.D.		Art Unit 1797	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0012613	01-2002	Scordato et al.	422/100
*	B	US-4,909,991	03-1990	Oshikubo, Yuji	422/100
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	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

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